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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

This application is a CON of 09/497,080 02/02/2000 PAT 6,737,328  
 which is a DIV of 09/113,467 07/10/1998 PAT 6,759,306

\*\* FOREIGN APPLICATIONS \*\*\*\*\*

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
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Foreign Priority claimed <input type="checkbox"/> yes <input checked="" type="checkbox"/> no 35 USC 119 (a-d) conditions <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Verified and Acknowledged	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> Met after met Examiner's Signature Initials	STATE OR COUNTRY ID	SHEETS DRAWING 3	TOTAL CLAIMS 46	INDEPENDENT CLAIMS 6
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 021567  
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TITLE  
 Methods of forming silicon dioxide layers, and methods of forming trench isolation regions

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